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Study on Charge Transport through a Molecule-Silicon Junction by Scanning Tunneling Microscopy

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Study on Charge Transport through a Molecule-Silicon Junction by Scanning Tunneling Microscopy

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The current-voltage (I-V) characteristics of organic molecules anchored covalently to silicon surfaces were studied with a scanning tunneling microscope in ultrahigh vacuum. It was found that molecules on silicon were not stable in the I-V measurement. Molecules were removed during the measurement, which was possibly induced by charge injection. Artificial negative differential resistance was sometimes recorded in the I-V plot. The origin of this event was explained by deformation and/or desorption of molecules induced by the charge injection during observation.

Keywords: molecular electronics; negative differential resistance; organic molecule; silicon; STM

INTRODUCTION

The molecular electronics has attracted interest as a candidate to break through the processing limit of inorganic semiconductor devices [1]. It has recently been demonstrated that simple molecular components

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exhibit interesting characteristics such as negative differential resistance (NDR) [2], rectifying [3], and switching [4]. Although the metal-molecule junction system, especially the Au–S bond, has been widely used to build molecular devices, the interface of the Au–S bond has not yet been well characterized. As a promising candidate in place of the Au–S junction, the hybridization of organic molecules and silicon substrates, the silicon-carbon (Si–C) junction, has recently been received considerable attention [5]. In recent studies, NDR has been discussed in I–V measurements on metal tip/vacuum/molecule/silicon systems using a scanning tunneling microscope (STM) [6,7]. NDR is one of the most challenging events in the molecular-scale electronics because of its application to the fast speed switching and the high performance oscillation circuits. The understanding of charge transfer and NDR event through the silicon-molecule system is, however, still insufficient. In this study, we show STM images and I–V characteristics through cyclopentene and 1,5-cyclooctadiene (COD) on Si(100)-2x1 surface using an ultrahigh vacuum (UHV) STM, and discuss the origin of NDR-like curves observed.

EXPERIMENTAL

All experiments were performed in the UHV STM (JEOL, JSPM-4500) system with the base pressure of 6.0×10^{-9} Pa. An electrochemically polished polycrystalline W wire with a diameter of 0.3 mm was used as an STM tip. Silicon substrates ($1 \times 7 \times 0.3$ mm³) were cut from n-type Si(100) wafers (0.1–0.2 Ω cm). Silicon substrates were outgassed for 12 hours and flashed in the UHV chamber prior to use. Cyclopentene (Wako, 95%) and 1,5-cyclooctadiene (Wako, 98%) were introduced through a variable leak valve after degassing by the freeze-pump-thaw cycle. The silicon substrate after the exposure to molecules was transferred to a STM stage, and STM observation was carried out at room temperature. STM images were taken over the same area before, during, and after the I–V measurement of the molecule.

RESULTS AND DISCUSSION

Figure 1(a) shows a STM image before the I–V measurement of Si(100)-2 \times 1 surface exposed to 0.01 langmuir (1 langmuir = exposure at 1×10^{-6} Torr for 1 sec) of cyclopentene molecules. Two cyclopentene molecules are recognized as blight spots. The sample bias (V_s) was set at -1.2 V and the tunneling current (I_t) was 0.5 nA. Almost the same images have been reported by several groups [7,8], in which the molecules were confirmed to anchor to Si(100)-2 \times 1 surface via the [2 + 2]

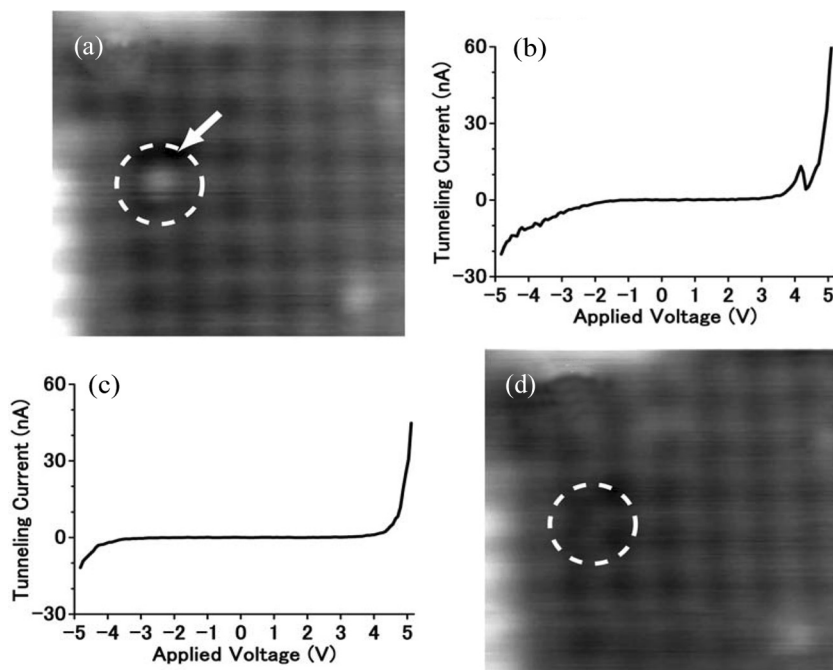


FIGURE 1 (a, d) STM images of Si(100)- 2×1 surface with cyclopentene molecules before (a) and after (d) I-V measurement: $5 \times 5 \text{ nm}^2$, $V_s = -1.2 \text{ V}$, $I_t = 0.5 \text{ nA}$. (b, c) I-V plots taken over the molecule (b) and clean Si(100)- 2×1 (c).

cycloaddition reaction. Figure 1(b) shows the I-V characteristics measured over a cyclopentene molecule indicated by an arrow in Figure 1(a). The sample bias voltage was swept from -5 V to $+5 \text{ V}$ and the I-V plot was recorded with 128 points. It is noted that a NDR-like peak was observed at the bias of around $+4 \text{ V}$ in the I-V plot. NDR-like peaks were sometimes observed at the negative bias in I-V plots, while no noticeable peaks were detected for bare Si(100) as shown in Figure 1(c). Figure 1(d) shows a STM image of the same area taken after the I-V measurement with $V_s = -1.2 \text{ V}$ and $I_t = 0.5 \text{ nA}$. It is noticed that a molecule was removed from the original position. Similar effect was frequently observed in I-V measurements of cyclopentene on the Si(100)- 2×1 surface [7]. The molecule was desorbed due to the I-V measurement.

Figure 2(a) shows a STM image of Si(100)- 2×1 surface exposed to 0.03 langmuir of COD molecules with $V_s = -1.2 \text{ V}$ and $I_t = 0.3 \text{ nA}$. Four COD molecules are recognized as blight spots. Similar images have been reported in previous studies [5]. Figure 2(b) shows a STM

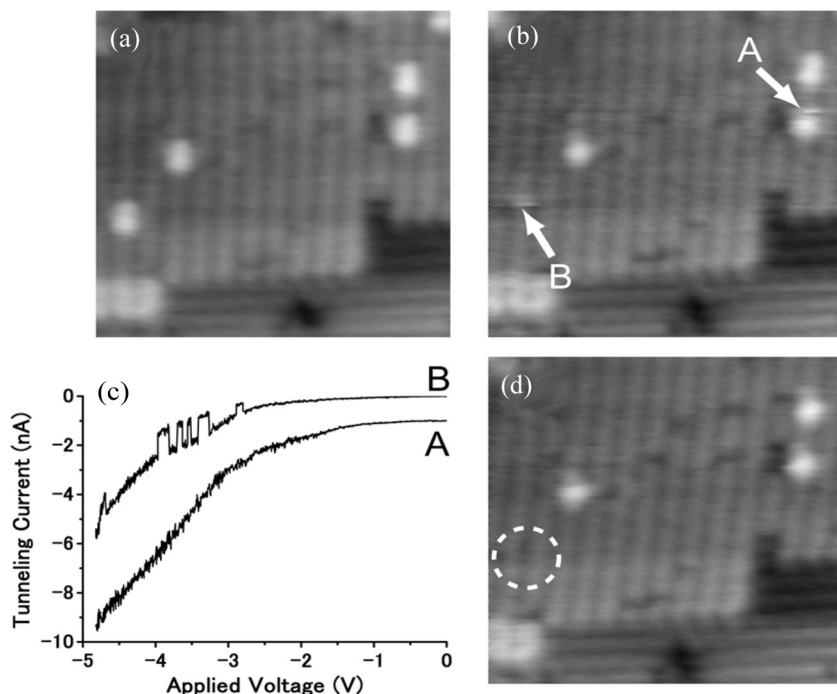


FIGURE 2 (a, b, d) STM images of Si(100)-2 × 1 surface with COD molecules before (a), during (b) and after (d) I-V measurement: 10 × 10 nm², V_s = −1.2 V, I_t = 0.3 nA; (c) I-V plot taken over molecules “A” and “B” shown in Figure 2(b).

image of COD on Si(100)-2 × 1 with V_s = −1.2 V and I_t = 0.3 nA, in which, during the scanning, the I-V measurement was carried out on the molecules labeled “A” and “B”. It should be noted that a molecule “B” was decomposed just after the I-V measurement. No noticeable change was observed for the molecule “A” in the image. Figure 2(c) shows the I-V characteristics measured over COD molecules labeled “A” and “B”. The sample bias voltage was swept from 0 V to −5 V and the I-V plot was recorded with 1024 points. Noticeable changes in current were randomly appeared on the I-V curve taken over a molecule “B”, while significant changes were not observed for a molecule “A”. Figure 2(d) shows a STM image after the I-V measurement of Si(100)-2 × 1 surface with V_s = −1.2 V and I_t = 0.3 nA. The desorption of the molecule “B” from the Si(100)-2 × 1 surface was confirmed in comparison to the image in Figure 2(a). The desorption of molecule from Si(100)-2 × 1 through the Si–C bond breaking is thought to play a key role to generate NDR-like events as demonstrated in Figure 2. NDR-like

events could be explained not by a resonant tunneling model but by decomposition and/or desorption of molecules. The sharp increase/decrease in the tunneling current was thought to be due to the inelastic electron scattering within organic molecules which induces the Si–C bond breaking as pointed out by Pitters *et al.* [7].

In summary, we confirmed that the cyclopentene and COD molecules anchored to Si(100)- 2×1 surfaces were not stable against the I-V measurement. The NDR-like event was induced by deformation and/or desorption of molecules following the carrier injection.

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